IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re th	ne Application of:	1
Won-Ick Jang, et al.		Art Group:
Application No.:		Examiner:
Filed:		
For:	STICTION-FREE MICROSTRUCTURI RELEASING METHOD FOR FABRICATING MEMS DEVICE - UTILITY	
Assistant Commissioner for Patents Washington, D.C. 20231		
TRANSMITTAL OF FORMAL DRAWINGS		
Sir:		
Enclosed herewith for filing in the above-identified U.S. Patent Application are the formal drawings,		
8 sheets including 12 Figures. Applicant hereby authorizes any additional extension or petition fees under 37		
C.F.R. §1.17 or credit for any overpayment to our Deposit Account No. 02-2666. A copy of the Fee		
Transmittal sheet is enclosed.		
	R	espectfully submitted,
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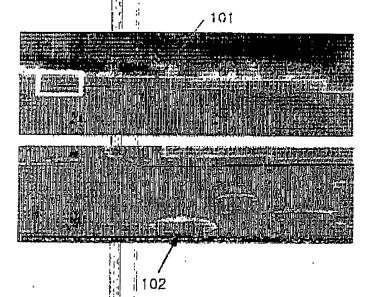
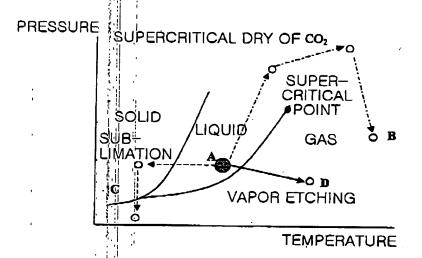
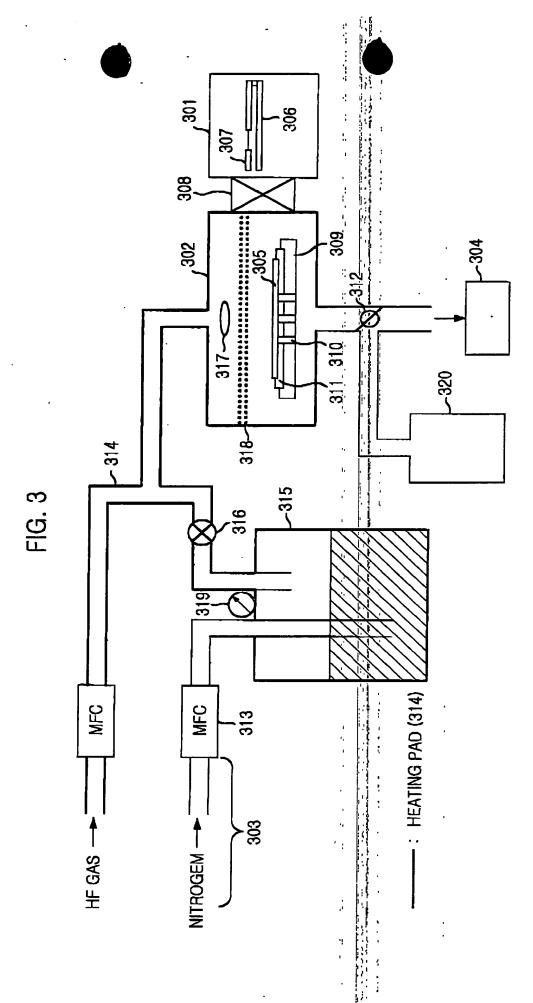


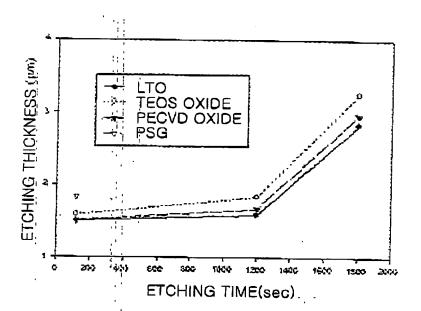
FIG. 2





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FIG. 4





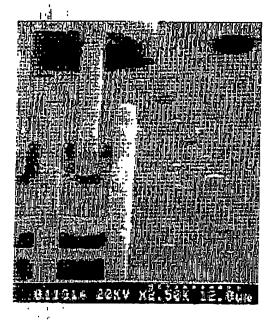
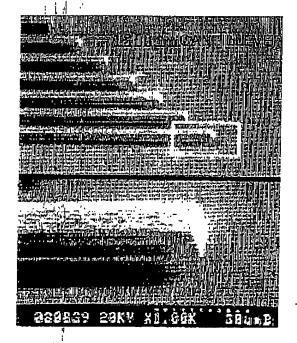
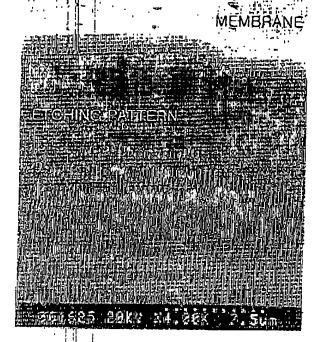


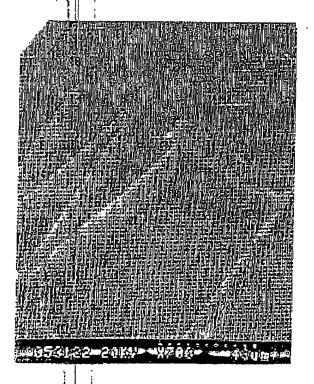
FIG. 6







F!G. 8





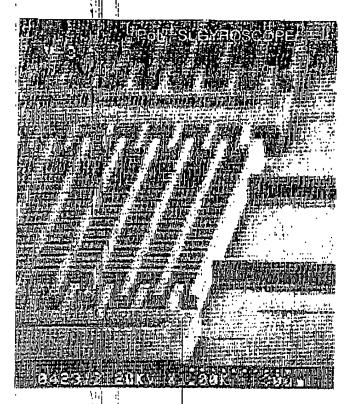
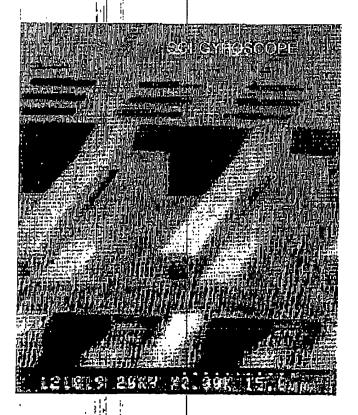


FIG. 10





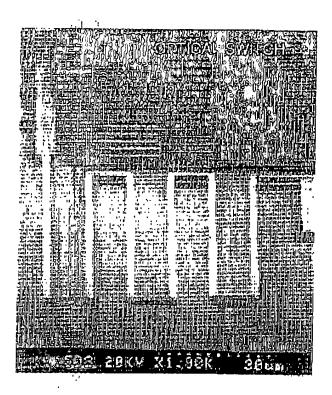


FIG. 12

